## E: RESISTIVE ELEMENT APPARATUS AND METHOD INVENTORS NAME: Chee-Yee Chung et al. DOCKET NO.: 884.538US1

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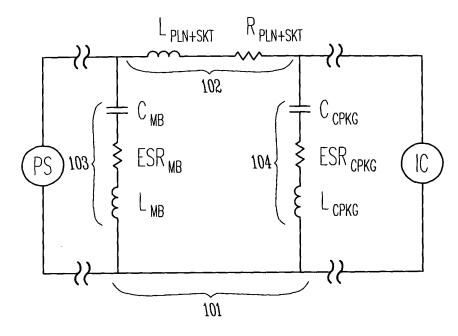


Fig. 1 (Prior Art)

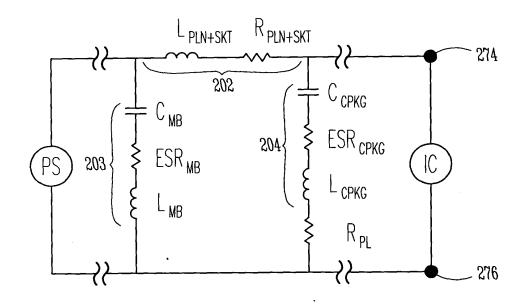
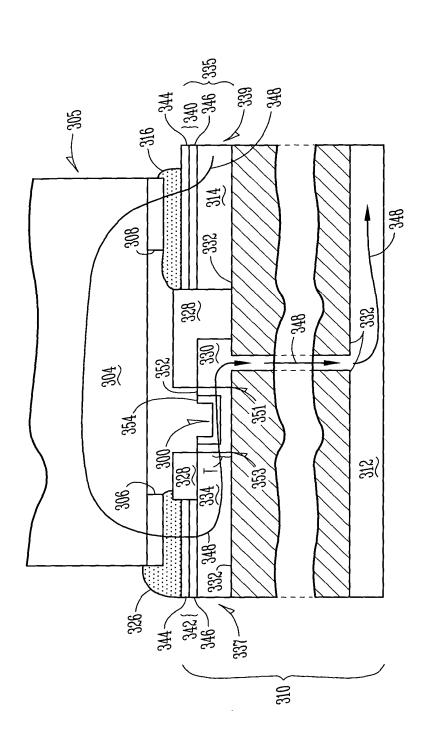


Fig.2

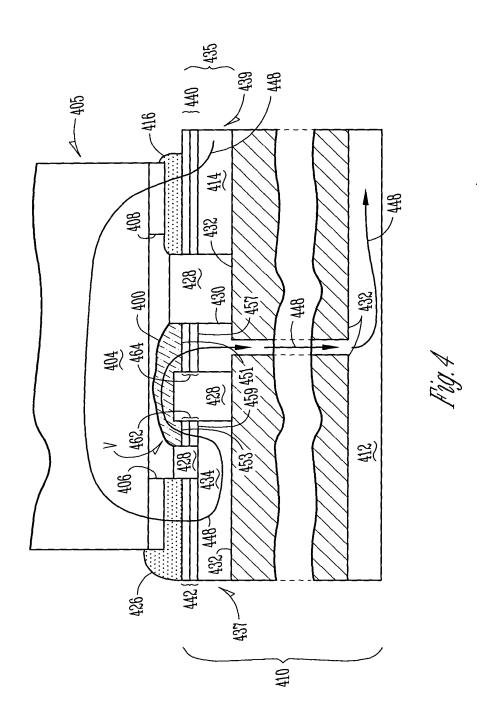
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Pig.3

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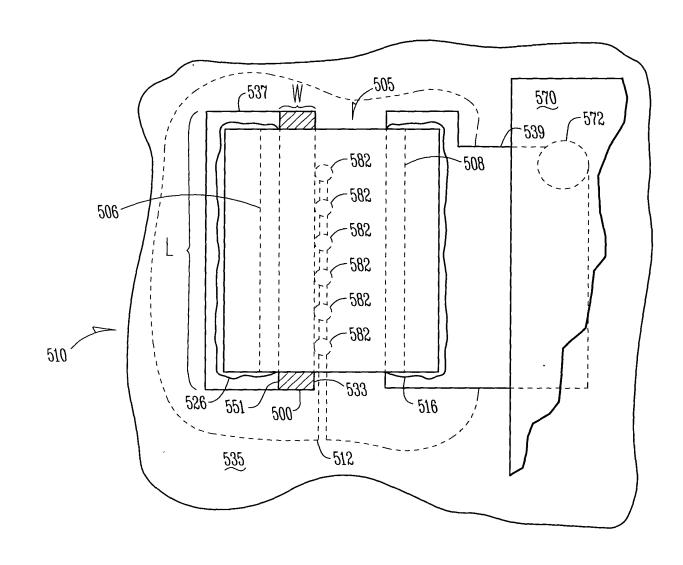


Fig.5

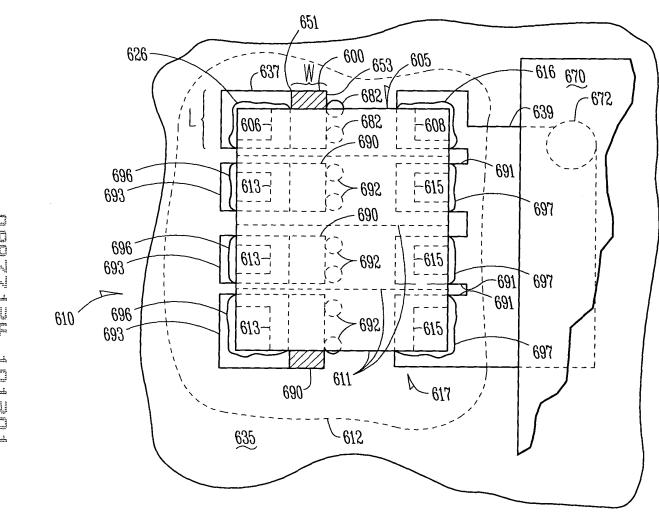


Fig. 6

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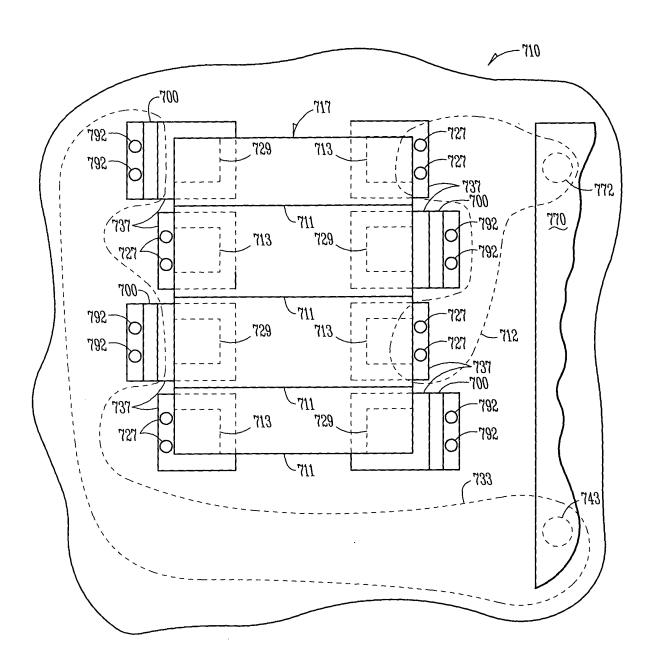


Fig. 7

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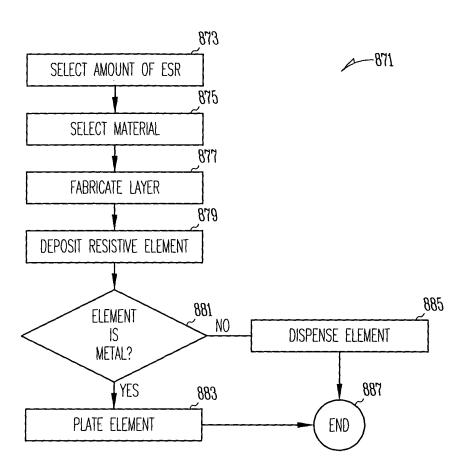


Fig. 8